

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**In re United States Patent Application of:****Applicant:** Peter Van Buskirk, et al.**Application No.:** 09/200,495**Date Filed:** November 25, 1998**Title:** OXIDATIVE TOP
ELECTRODE DEPOSITION
PROCESS, AND
MICROELECTRONIC
DEVICE STRUCTURE**Docket No.:** 2771-337 RCE (7482)**Examiner:** S. Hu**Art Group:** 2811**23448**

PATENT TRADEMARK OFFICE

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Number of Pages (including cover)**Lee Ann Brown****May 15, 2001****Date**FAX COPY RECEIVED
MAY 15 2001
TECHNOLOGY CENTER 2800**PLEASE IMMEDIATELY HAND-DELIVER TO EXAMINER SHOUXIANG HU
(TELEPHONE: 703-306-5729)****RESPONSE TO APRIL 18, 2001 OFFICE ACTION
IN U.S. PATENT APPLICATION NO. 09/200,495**Commissioner for Patents
Washington, D.C. 20231

Sir:

This responds to the April 18, 2001 Office Action in the above-identified patent application.